EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	983	semiconductor near fabrication near apparatus	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/28 10:01
L2	23015	Applied.as.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/28 10:01
L3	28	1 and 2	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/28 10:05
L4	73804	electron.as.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/28 10:05
L5	503	1 and wafer	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/28 10:06
L6	26	4 and 1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/28 12:01
L7	18	"6795377"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/28 12:02
L8	9	"6795337"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/28 14:26
L9	1	10/806520	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/28 14:44
L10	48043	interconnection	US-PGPUB	OR	ON	2006/02/28 14:44
L11	6368	10.clm.	US-PGPUB	OR	ON	2006/02/28 14:45

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L12	2803	stacked with chip	US-PGPUB	OR	ON	2006/02/28 14:45
L13	1264	stacking with chip	US-PGPUB	OR	ON	2006/02/28 14:45
L14	3187	12 13	US-PGPUB	OR	ON	2006/02/28 14:45
L15	756	14.clm.	US-PGPUB	OR	ON	2006/02/28 14:45
L16	62	11 and 15	US-PGPUB	OR	ON	2006/02/28 14:46
L17	550	metal near (standoff spacer)	US-PGPUB	OR	ON	2006/02/28 14:46
L18	105	17.clm.	US-PGPUB	OR	ON	2006/02/28 14:47
L19	1	16 and 18	US-PGPUB	OR	ON	2006/02/28 14:47